



PATENT  
81839.0077

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Teruaki FUKAMI

Serial No: 09/218,997

Filed: December 22, 1998

For: SILICON WAFER STORAGE WATER  
AND SILICON WAFER STORAGE  
METHOD

Date of NOA: April 13, 2004

Art Unit: 1744

TRANSMITTAL OF ISSUE FEE

Mail Stop ISSUE FEE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to:

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Commissioner for Patents  
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June 1, 2004

Date of Deposit

Rebecca L. Golden

Name

*Rebecca L. Golden* June 1, 2004

Signature

Date

In response to the Notice of Allowance dated April 13, 2004, enclosed are the following:

- ☒ Form Part B - Issue Fee Transmittal and a check in the amount of \$ 1660.00 in payment of the Issue Fee, Publication Fee and in payment of the Advance Order for 10 patent copies (at \$3.00 per copy).
- ☒ An Information Disclosure Statement citing three references is being filed concurrently herewith.

The Commissioner is hereby authorized to charge any deficiency in payment or credit any overpayment to Deposit Account No. 50-1314. A copy of this Transmittal is enclosed.

Respectfully submitted,

HOGAN & HARTSON L.L.P.

Date: June 1, 2004

By:

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